# LabAdviser update: 13/8 2019

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| Updated Subject | Contributor | Link to the updated pages |
| **New info on the resist nLof**  New process flow document on nLof and separate documents for the other resists have been made. | **Thomas Anhøj @Nanolab** | [Lithography/UVLithography#Resist\_Overview](http://labadviser.nanolab.dtu.dk/index.php/Specific_Process_Knowledge/Lithography/UVLithography#Resist_Overview) |
| **PECVD3**  Silicon deposition in PECVD3 has been added.  *If any users have other recipes we can add then please let me know.* | **Berit Herstrøm @Nanolab** | [Deposition\_of\_Silicon/Si\_deposition\_using\_PECVD](http://labadviser.nanolab.dtu.dk/index.php/Specific_Process_Knowledge/Thin_film_deposition/Deposition_of_Silicon/Si_deposition_using_PECVD) |
| **Si isotropic etch in ICP metal**  Tested new settings | **Lior Shiv @Capres** | [ICP\_Metal\_Etcher/silicon/isotropic#Isotropic\_etching\_in\_silicon\_on\_the\_ICP\_Metal\_Etch](http://labadviser.nanolab.dtu.dk/index.php/Specific_Process_Knowledge/Etch/ICP_Metal_Etcher/silicon/isotropic#Isotropic_etching_in_silicon_on_the_ICP_Metal_Etch) |
| **Tech Forum slides**  **The newest Tech Forum slides have been added** | **Anders Jørgensen @Nanolab** | [/Surveys\_and\_statistics#Tech\_Forum\_slides](http://labadviser.nanolab.dtu.dk/index.php/Surveys_and_statistics#Tech_Forum_slides) |

# Equipment Manuals updated in LabManager (since 3rd of May):

As an approved user on a piece of equipment you have to make sure you have read and understood the latest version of the manual before using the equipment.

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| Manual for Four point probe-Jandel, ver 1 |
| Manual for ALD 1, ver 4 |
| Manual for Thermal Evaporator, ver 1.2 |
| Manual for LPCVD polysilicon furnace (4"), ver 6.2 |
| Manual for ellipsometer M-2000V, ver 2.4 |
| Manual for Aligner: Maskless 02, ver 1 |
| Manual for FilmTek, ver 1.7 |
| Manual for Dektak 3ST, ver 7 |
| Manual for Hotplate (SU8), ver 3.2 |
| Manual for E-Beam Evaporator (Temescal), ver 2 |
| Manual for RCA clean, ver 6 |
| Manual for SEM Tabletop 1, ver 1.2 |